

Docket No.: 50212-225



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Hiroyuki ITO, et al.

Serial No.: 09/830,631

Filed: April 30, 2001

For: ION IMPLANTATION APPARATUS

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Group Art Unit: 2878

Examiner:

**RECEIVED**

**AUG 0 8 2001**

**Technology Center 2100**

**LETTER RESPONDING TO NOTIFICATION OF MISSING REQUIREMENTS UPON  
RECEIPT OF NOTIFICATION OF ACCEPTANCE**

Commissioner for Patents  
Washington, DC 20231

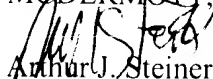
Sir:

We received the Notice of Missing Parts of Application dated June 6, 2001. On June 15, 2001, we contacted Ms. Kidwell of the PCT Division of the USPTO and informed her the Declaration was filed with the application and provided a Fax copy of the Declaration and evidence of its filing in the USPTO on April 30, 2001. After subsequent phone conversations with Ms. Kidwell she indicated she had located the Declaration in the file.

We have now received the Notification of Acceptance and official Filing Receipt for this above identified application and therefore believe that all requirements have been met.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

  
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